



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Achintya K. Bhowmik

Serial No.: 10/669,938

Filed: September 24, 2003

For: Tunable Dispersion Compensation  
Using A Photoelectric Medium

§ Group Art Unit:

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Examiner:

Atty. Dkt. No.: ITL.1014US (P16650)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT


Dear Sir:

Applicant submits the references listed on the attached form PTO 1449 together with any required copies of such references.

This statement is being filed within three months of the filing date of the application.  
Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.1014US).

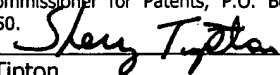
Respectfully submitted,

Date: 12/4/03

  
Timothy N. Trop, Registration No. 28,994  
TROP, PRUNER & HU, P.C.  
8554 Katy Freeway, Suite 100  
Houston, Texas 77024  
(713) 468-8880 [Phone]  
(713) 468-8883 [Fax]

Date of Deposit: December 4, 2003

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
Sherry Tipton

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	ATTY DOCKET NO. ITL.1014US (P16650)	SERIAL NO. 10/669,938
	APPLICANT(S): ACHINTYA K. BHOWMIK	
	FILING DATE: September 24, 2003	GROUP ART UNIT:

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.					
	B.					
	C.					
	D.					
	E.					
	F.					
	G.					
	H.					

### FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
I.						
J.						
K.						
L.						
M.						
N.						
O.						

### OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

P.	Bhowmik, "On Photoelastic Stress Measurements in Optically Absorbing Medium", Optics Communications 210 (2002), pp. 165-172
Q.	Bhowmik, "Multiple-Reflection Effects in Photoelastic Stress Analysis", Applied Optics, Vol. 40, No. 16, June 1, 2001, pp.2687-2691
R.	
S.	
T.	
U.	
V.	

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.